



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov

**\*BIBDATASHEET\***

CONFIRMATION NO. 2823

Bib Data Sheet

SERIAL NUMBER 10/822,751	FILING DATE 04/13/2004  RULE	CLASS 165	GROUP ART UNIT 3743	ATTORNEY DOCKET NO. SEC.736D
-----------------------------	---------------------------------------	--------------	------------------------	------------------------------------

## APPLICANTS

Choung Hyep Kim, Suwon-city, KOREA, REPUBLIC OF;

Sung Il Jang, Kwacheon-city, KOREA, REPUBLIC OF;

Kyung Seo Park, Yongin-city, KOREA, REPUBLIC OF; Ki Hyon Chyun, Suwon-city, KOREA, REPUBLIC OF;

Hee Sun Chae, Suwon-city, KOREA, REPUBLIC OF;

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a DIV of 09/605,660 06/28/2000 PAT 6,746,972

*KAY, TM*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

REPUBLIC OF KOREA 99-25341 06/29/1999

*KAY, TM*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 06/23/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 7	TOTAL CLAIMS 5	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature	Initials		

## ADDRESS

20987

VOLENTINE FRANCO, &amp; WHITT PLLC

ONE FREEDOM SQUARE

11951 FREEDOM DRIVE SUITE 1260

RESTON, VA

20190

## TITLE

Apparatus for and method of heat-treating a wafer